

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Volker Härle et al.	Art Unit :	2892
Serial No. :	10/813,530	Examiner :	Chuong A. Luu
Filed :	March 29, 2004	Conf. No. :	5329
Title :	METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED ON A NITRIDE COMPOUND SEMICONDUCTOR		

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JUNE 26, 2008

Please amend the above-identified application as follows: